

<b>Notice of References Cited</b>	Application/Control No. 09/696,955	Applicant(s)/Patent Under Reexamination TAMURA ET AL.	
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#### U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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#### NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
X	U	Wolf et al., Silicon Processing for the VLSI Era, Volume 1: Process Technology, Lattice Press, Sunset Beach, CA, USA, pp. 8-, 23-27, 32-33, 59, 529-532, 1986.		
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Matthew Anderson

6/01/04

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